

<b>Notice of References Cited</b>	Application/Control No. 10/046,601	Applicant(s)/Patent Under Reexamination HEPLER, EDWARD L.	
	Examiner Kaveh Abrishamkar	Art Unit 2131	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,747,947 B2	06-2004	Kim et al.	370/209
*	B	US-6,552,996 B2	04-2003	Kim et al.	370/209
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**NON-PATENT DOCUMENTS**

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